



1700

ACT Receipt #5

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Unknown

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING

RECEIVED  
JAN 22 2002  
TC 1700

**SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

Sir:

We enclose a copy of the Corrected Official Filing Receipt, as well as the first Request for Corrected Official Filing Receipt, for the above-identified application and request the following correction:

**IN THE TITLE:** delete "fro" and insert therefor --for--.

Verification for the requested correction is indicated on the first Request for Corrected Official Filing Receipt filed April 19, 2001, as well as the original Declaration and Power of Attorney filed February 20, 2001.

Respectfully submitted,

Christopher R. Lipp  
Registration No. 41,157

SUGHRUE MION, PLLC  
2100 Pennsylvania Avenue, N.W.  
Washington, D.C. 20037-3213  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

Date: December 5, 2001

Attorney Docket No.: Q63075



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
www.uspto.gov

| APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO. | DRAWINGS | TOT CLAIMS | IND CLAIMS |
|--------------------|-------------|--------------|---------------|------------------|----------|------------|------------|
| 09/763,194         | 02/20/2001  | 1725         | 1020          | Q63075           | 8        | 13         | 5          |

Sughrue Mion Zinn  
Macpeak & Seas  
2100 Pennsylvania Avenue NW  
Washington, DC 20037



CONFIRMATION NO. 3832

CORRECTED FILING RECEIPT



\*OC000000007052980\*

Date Mailed: 11/09/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Kazunobu Fujikawa, Tokyo, JAPAN;  
Akihiro Goto, Tokyo, JAPAN;

RECEIVED

JAN 22 2002

TC 1700

## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/02379 05/07/1999

## Foreign Applications

If Required, Foreign Filing License Granted 03/21/2001

Projected Publication Date: Not Applicable, filed prior to November 29,2000

Non-Publication Request: No

Early Publication Request: No

## Title

Method and apparatus for surface discharge processing, and an electrode[fr]surface  
discharge processing

## Preliminary Class

219

---

**LICENSE FOR FOREIGN FILING UNDER  
Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

**GRANTED**

The applicant has been granted a license under 35 U.S.C. 184, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" followed by a date appears on this form. Such licenses are issued in all applications where the conditions for issuance of a license have been met, regardless of whether or not a license may be required as set forth in 37 CFR 5.15. The scope and limitations of this license are set forth in 37 CFR 5.15(a) unless an earlier license has been issued under 37 CFR 5.15(b). The license is subject to revocation upon written notification. The date indicated is the effective date of the license, unless an earlier license of similar scope has been granted under 37 CFR 5.13 or 5.14.

This license is to be retained by the licensee and may be used at any time on or after the effective date thereof unless it is revoked. This license is automatically transferred to any related applications(s) filed under 37 CFR 1.53(d). This license is not retroactive.

The grant of a license does not in any way lessen the responsibility of a licensee for the security of the subject matter as imposed by any Government contract or the provisions of existing laws relating to espionage and the national security or the export of technical data. Licensees should apprise themselves of current regulations especially with respect to certain countries, of other agencies, particularly the Office of Defense Trade Controls, Department of State (with respect to Arms, Munitions and Implements of War (22 CFR 121-128)); the Office of Export Administration, Department of Commerce (15 CFR 370.10 (j)); the Office of Foreign Assets Control, Department of Treasury (31 CFR Parts 500+) and the Department of Energy.

**NOT GRANTED**

No license under 35 U.S.C. 184 has been granted at this time, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" DOES NOT appear on this form. Applicant may still petition for a license under 37 CFR 5.12, if a license is desired before the expiration of 6 months from the filing date of the application. If 6 months has lapsed from the filing date of this application and the licensee has not received any indication of a secrecy order under 35 U.S.C. 181, the licensee may foreign file the application pursuant to 37 CFR 5.15 (b).



36

**FILING RECEIPT**  
**PLEASE DATE STAMP AND RETURN TO US - BOX 235X**

In re application of

KAZUNOBU FUJIKAWA, et al.

Appln. No. 09/763,194

Group Art Unit: 1725

Confirmation No.: Not yet assigned

Examiner: Not yet assigned

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN  
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

PAPER(S) FILED ENTITLED:

1. Request For Corrected Official Filing Receipt, with copy of marked-up Official Filing Receipt
2. copy of Declaration and Power of Attorney

SUGHRUE, MION, ZINN,  
MACPEAK & SEAS, PLLC  
2100 Pennsylvania Avenue, N.W.  
Washington, D.C. 20037-3213  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

DOCKET NO.: Q63075  
ATTORNEY/SEC: RCT:te

Date Filed: April 19, 2001

**RECEIVED**  
**JAN 22 2002**  
**TC 1700**



2001 MAR 19 10 5:15

RECEIVED  
POS



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

KAZUNOBU FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: Not yet assigned

Examiner: Not yet assigned

Filed: February 20, 2001

RECEIVED  
JAN 22 2002  
TC 1700

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN  
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

FILED  
APR 19 2001

Sir:


We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction(s):

**TITLE:** delete "METHOD AND APPARATUS FOR SURFACE TREATMENT BY ELECTRODISCHARGING, AND DISCHARGE ELECTRODE" and insert --METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING--

Verification for the requested correction(s) is indicated on the original Declaration and Power of Attorney filed February 20, 2001.

SUGHRUE, MION, ZINN,  
MACPEAK & SEAS, PLLC  
2100 Pennsylvania Avenue, N.W.  
Washington, D.C. 20037-3213  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

Respectfully submitted,

  
Richard C. Turner  
Registration No. 29,710

Date: April 19, 2001